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Niobium ethoxide analyzed by XPS

Sergio A. Rincón-Ortiz¹, Jhonatan Rodriguez-Pereira^{1,2} and Rogelio Ospina^{1,a)}

¹Centro de Investigación Científica y Tecnológica en Materiales y Nanociencias (CMN), Universidad Industrial de Santander, Piedecuesta, Santander, P.C. 681011, Colombia.

²Center of Materials and Nanotechnologies, Faculty of Chemical Technology, University of Pardubice, Nam. Cs. Legii 565, 53002 Pardubice, Czech Republic.

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Niobium (V) ethoxide was characterized by x-ray photoelectron spectroscopy (XPS). The specimen is a powder purchased from Sigma Aldrich. Sample was fixed to a stainless-steel sample holder with copper double-sided adhesive tape. Survey spectra, Nb 3d, O 1s, C 1s, Nb 3p, Nb 4p, O 2s core levels and valence band spectra were acquired. Results showed how the elements in niobium ethoxide structure are bonded.

Keywords: Niobium ethoxide; XPS; precursor; niobium ethanolate

INTRODUCTION

Niobium (V) ethoxide (Fig. 1) is a colorless to yellow organometallic compound, easily hydrolyzable and soluble in some organic solvents such as ethanol, it has a relative density of 1.268 g/cm^3 at 25 °C. It is widely used as a precursor for different processes, such as the generation of niobium oxide films by CVD (Refs 1 - 3), for applications in devices in the electronic and optical industry. Another important method that uses niobium ethoxide as a precursor to generate NbO or LiNbO₃ films is the sol-gel Refs. 3 - 5). These niobium oxides have a very high dielectric constant in thin films, being used by this property for memories (DRAMs) (Ref. 6). Furthermore, it is also used to produce Nb₂O₅, which is widely used for photocatalytic processes (Ref. 7).

С

Fig. 1. Structure of niobium ethoxide

XPS survey spectrum indicates that there are no intrusive elements in the sample, since the presence of just carbon, oxygen and niobium is evidenced.

Nb 3d high resolution spectrum was fitted with four contributions corresponding to two different chemical species. The peaks centered at 207.2 and 209.9 eV were assigned to niobium bonded with oxygen, O-**Nb**-O, and signals at 208.4 and 211.1 eV were

Accession#: 01676

Technique: XPS

Host Material: Niobium ethoxide

Instrument: SPECS PHOIBOS 150

Major Elements in Spectra: Nb, O, C

Minor Elements in Spectra: None

Published Spectra: 6

Spectra in Electronic Record: 6

Spectral Category: comparison

associated with niobium bonded with oxygen related with carbon, **Nb**-O-C. High resolution spectrum of O 1s shows three chemical environments. **O**-Nb-**O** at 530.5 eV, oxygen bonded with bismuth. C-**O** at 532.2 eV, oxygen single bonded with carbon. And, C-**O**-Nb at 533.7 eV, oxygen bonded with carbon and niobium. C 1s spectrum displays three chemical species. First, carbon carbon bonding or adventitious carbon, C-(C,H) at 284.8 eV used as a reference (Ref. 8). Second, carbon single bounded with oxygen, C-O at 286.5 eV. And, carbon single bonded with oxygen related with niobium, C-O-Nb at 288.8 eV.

SPECIMEN DESCRIPTION (ACCESSION # 01676)

Host Material: Niobium ethoxide

CAS Registry #: 3236-82-6

Host Material Characteristics: homogeneous; solid; polycrystalline; unknown conductivity; metalorganic compound; Powder

Chemical Name: Niobium ethoxide

Source: Sigma Aldrich

Host Composition: Niobium (V) ethoxide (99.95%)

Form: Powder

Structure: Nb(OCH₂CH₃)₅

History & Significance: Niobium (V) ethoxide powder was ground and fixed to a sample holder with copper $3M^{TM}$ double-sided adhesive tape. The sample was exposed to the environment for about 2 minutes, time that was spent to prepare the sample and then introduce it to the platform.

As Received Condition: As powder

Analyzed Region: same as host material

Ex Situ Preparation/Mounting: As received.

In Situ Preparation: None

Charge Control: Electron flood gun (SPECS FG-500) operated at 70 μA and 4eV

Temp. During Analysis: 300 K

Pressure During Analysis: < 1 x 10⁻⁷ Pa

Pre-analysis Beam Exposure: 60 s

INSTRUMENT DESCRIPTION

Manufacturer and Model: SPECS PHOIBOS 150 – 2D-DLD - SPECS Surface Nano Analysis GmbH

Analyzer Type: spherical sector

Detector: other

Number of Detector Elements: 25

INSTRUMENT PARAMETERS COMMON TO ALL SPECTRA

■ Spectrometer

Analyzer Mode: constant pass energy

Throughput (T=E^N): N=0

Excitation Source Window: Mylar window, allows high X-ray transmission: 88% for Al Kα.

Excitation Source: Al Ka monochromatic

Source Energy: 1486.6 eV

Source Strength: 200 W

Source Beam Size: 2000 μm x 2000 μm

Signal Mode: multichannel direct

■Geometry

Incident Angle: 55 °

Source-to-Analyzer Angle: 55 °

Emission Angle: 0 °

Specimen Azimuthal Angle: Not applicable

Acceptance Angle from Analyzer Axis: 16 °

Analyzer Angular Acceptance Width: 16 ° x 16 °

∎lon Gun

Manufacturer and Model: SPECS IQE 12/38

Energy: 5000 eV

Current: 70 mA

Current Measurement Method: biased stage

Sputtering Species: Ar⁺

Spot Size (unrastered): 3000 µm x 3000 µm

Raster Size: Not applicable $\mu m x \mu m$

Incident Angle: 54°

Polar Angle: 55°

Azimuthal Angle: 45°

Comment: The specimen was analyzed as loaded. The ion gun was used only for cleaning the Ag reference foil.

DATA ANALYSIS METHOD

Energy Scale Correction: Binding energy of the adventitious carbon, C-(C,H) at 284.8 eV (Ref. 8) was used as reference to adjust the binding energy scale of the spectra.

Recommended Energy Scale Shift: 2.76 eV

Peak Shape and Background Method: Peak position and width were determined from fitting the spectra using a mixed Gaussian– Lorentzian, GL (30) function after subtraction of a Shirley background using the CasaXPS Software.

Quantitation Method: Peak areas were obtained from fitting the spectra and relative sensitivity factors from the atomic photoionization cross section of each core level provided by SPECS Prodigy library.

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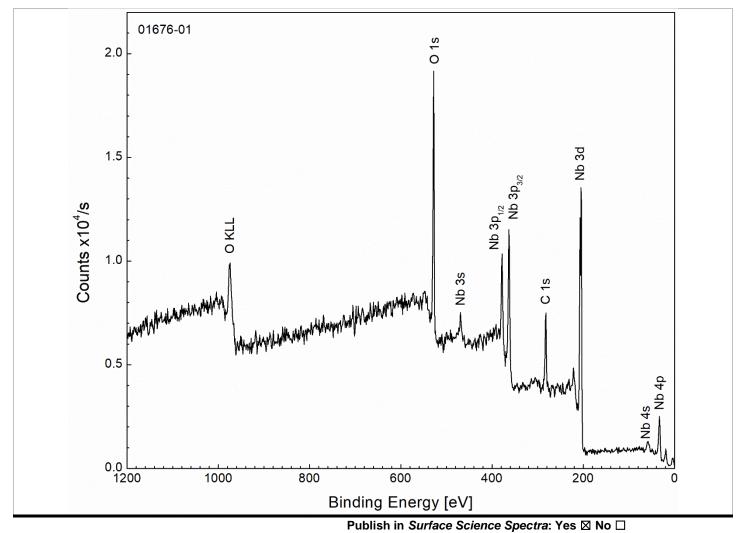
SPECTRAL FEATURES TABLE								
Spectrum ID #	Element/ Transition	Peak Energy (eV)	Peak Width FWHM (eV)	Peak Area (eV x cts/s)	Sensitivity Factor	Concentration (at. %)	Peak Assignment	
01676-02	Nb 3d			1.35x10 ⁴	8.21	17.72		
01676-02	Nb 3d5/2	207.2	1.37				0-Nb-0	
01676-02	Nb 3d _{3/2}	209.9	1.37				0-Nb-0	
01676-02	Nb 3d5/2	208.4	1.78				Nb-O-C	
01676-02	Nb 3d _{3/2}	211.1	1.78				Nb-O-C	
01676-03	O 1s			1.03x10 ⁴	2.77	44.79		
01676-03	O 1s	530.5	1.62				O -Nb- O	
01676-03	O 1s	532.2	1.62				C- O	
01676-03	O 1s	533.7	1.62				C- O -Nb	
01676-04	C 1s			3.42x10 ³	1.00	37.49		
01676-04	C 1s	284.8	1.79				C -(C,H)	
01676-04	C 1s	286.5	1.79				C -O	
01676-04	C 1s	288.8	1.79				C -O-Nb	
01676-05	Nb 3p _{3/2}	365.9	2.71	6.42x10 ³				
01676-05	Nb 3p _{1/2}	381.1	2.83	4.35x10 ³				
01676-06	Nb 4p	34.9	3.58	1.73x10 ³				
01676-06	O 2s	22.7	2.52	5.74x10 ²				
01676-06ª	VBM	2.35						

^a Valence band maximum (VBM)

ANALYZER CALIBRATION TABLE									
Spectrum ID #	Element/ Transition	Peak Energy (eV)	Peak Width FWHM (eV)	Peak Area (eV x cts/s)	Sensitivity Factor	Concentration (at. %)	Peak Assignment		
	Ag 3d _{5/2}	368.3	0.50	0.15x10 ⁶					

GUIDE TO FIGURES						
Spectrum (Accession) #	Spectral Region	Voltage Shift*	Multiplier	Baseline	Comment #	
01676-01	Survey	0	1	0	1	
01676-02	Nb 3d	-2.76	1	0	1	
01676-03	O 1s	-2.76	1	0	1	
01676-04	C 1s	-2.76	1	0	1	
01676-05	Nb 3p	-2.76	1	0	1	
01676-06	Nb 4p, O 2s, VB	-2.76	1	0	1	

*Voltage shift of the archived (as-measured) spectrum relative to the printed figure. The figure reflects the recommended energy scale correction due to a calibration correction, sample charging, flood gun, or other phenomenon. 1, Bismuth (III) acetate powder



Accession #	01676-01	
Host Material	Niobium ethoxide	
Technique	XPS	
Spectral Region	survey	
Instrument	SPECS PHOIBOS 150	
Excitation Source	Al Ka monochromatic	
Source Energy	1486.6 eV	
Source Strength	200 W	
Source Size	2 mm x 2 mm	
Analyzer Type	spherical sector analyzer	
Incident Angle	55°	
Emission Angle	0°	
Analyzer Pass Energy	100 eV	
Analyzer Resolution	1.7 eV	
Total Signal Accumulation Time	122 s	
Total Elapsed Time	260 s	
Number of Scans	1	
Effective Detector Width	5.28 eV	

